



Attorney's Docket No.: 12406-059US2 / 1998P1821 US2 N

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Haerle

Serial No. : 10/625,118

Filed : July 22, 2003

Title : METHOD OF PRODUCTION OF SEMICONDUCTOR COMPONENTS

Art Unit : Unknown

Examiner : Unknown

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

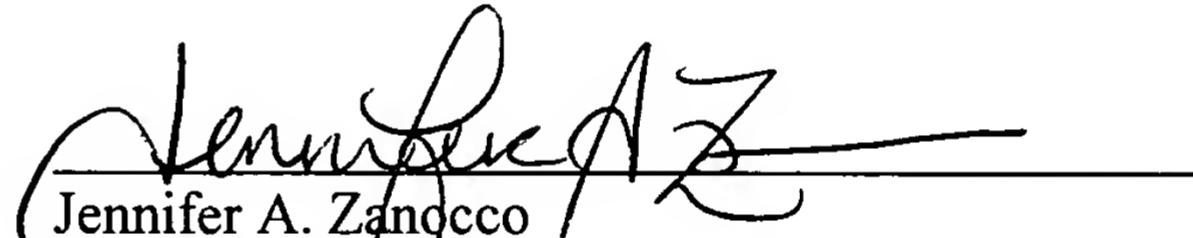
INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449.

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: November 10, 2003


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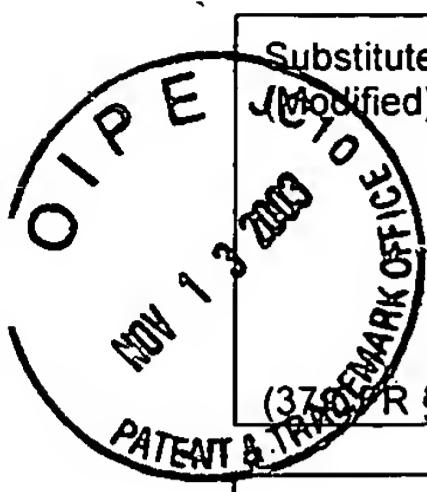
CERTIFICATE OF MAILING BY FIRST CLASS MAIL

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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12406-059US2	Application No. 10/625,118
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Volker Haerle	
		Filing Date July 22, 2003	Group Art Unit Unknown
(37 CFR §1.98(b))			

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document	
	AQ	Sugano, Hikaru, "Semiconductor Laser Manufacturing Method", October 27, 1989, pp. 1-6	
	AR		
	AS		
	AT		

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	